# **Special Issue**

# Special Applications of Microsensors

## Message from the Guest Editors

This Special Issue aims to present untypical applications of microsensors, both commercial MEMS devices as well as custom-built prototypes. Topics of interest include, but are not limited to, applications of MEMS accelerometers, MEMS gyroscopes, displacement sensors, and innovative microsensors, as well as original ideas involving direct and indirect measurements of various physical quantities by microsensors.

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## Deadline for manuscript submissions

closed (31 October 2021)



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## Message from the Editor-in-Chief

Sensors is a leading journal devoted to fast publication of the latest achievements of technological developments and scientific research in the huge area of physical, chemical and biochemical sensors, including remote sensing and sensor networks. Both experimental and theoretical papers are published, including all aspects of sensor design, technology, proof of concept and application. Sensors organizes Special Issues devoted to specific sensing areas and applications each year.

#### Editor-in-Chief

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